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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: : Wilbur G. Catabay and Wei-Jen Hsia  
Appl. No. : 09/884,736  
Filed: : June 19, 2001  
Title : PLASMA TREATMENT OF LOW DIELECTRIC CONSTANT  
DIELECTRIC MATERIAL TO FORM STRUCTURES USEFUL IN  
FORMATION OF METAL INTERCONNECTS AND/OR FILLED VIAS  
FOR INTEGRATED CIRCUIT STRUCTURE  
Grp./ A.U. : 2829  
Examiner : Lisa A. Kilday  
Docket No. : 00-654/RCE

RECEIVED  
APR 29 2003  
TECHNOLOGY CENTER 2800

PRELIMINARY AMENDMENT

Honorable Commissioner for Patents  
Washington, D.C. 20231

Date: April 24, 2003

Sir:

Please amend the accompanying RCE application as follows: